

IF 4/2888

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Aleksei MIKHAILOV et al.

Serial No: **10/526,217**

Filed : **March 1, 2005**

For : **SEMICONDUCTOR LASER DEVICE**



Group Art Unit: **2828**

Examiner: **Patrick Stafford**

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant received, on June 22, 2007, an Office Action issued by the Chinese Patent Office and in connection therewith applicant encloses a copy of JP 60-72473A. The document was cited in a communication from the Chinese Patent Office within the three month statutory window. It is believed that no fees are due or owing concerning this submission, but if fees are due or owing, please charge Deposit Account No. 08-2455 the deficiency.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Stewart L. Gitler".

Stewart L. Gitler
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July 26, 2007

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Attorney's Docket: **A-9472.SIDS2/bh**

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

A-9472

Application Number

10/526,217

Applicant(s)

Aleksei Mikhailov et al.

Filing Date

March 1, 2005

Group Art Unit

2828

PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		JP 60-72473A	04/24/1985	Japan				

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.